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## Overview of the Optics Fabrication and Metrology Group at the APS

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The capabilities and activities of OFM group at the APS will be summarized with an emphasis on new capabilities and recent results. A new work-request system for web-based submissions is available to all users of the APS and will be described. In the area of thin-film deposition, the presentation will include details for multilayers and profile coating. In the area of x-ray characterization the presentation will include topography of synthetic diamonds. In the area of crystal fabrication, the presentation will include some details on polished Si. Finally, a new type of optic called a multilayer Laue lens will be described, its fabrication steps summarized, and performance results presented.

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